

DOCKET NO.: 240882US0

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF	:	
TOMOHISA KONNO ET AL	:	EXAMINER: RACHUBA, MAURINA T.
SERIAL NO.: 10/626,521	:	
FILED: JULY 25, 2003	:	GROUP ART UNIT: 3723
FOR: AQUEOUS DISPERSION FOR CHEMICAL MECHANICAL POLISHING AND PRODUCTION PROCESS OF SEMICONDUCTOR DEVICE	:	"RESPONSE UNDER 37 CFR 1.116- EXPEDITED PROCEDURE EXAMINING GROUP <u>3723</u> "

AMENDMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated August 6, 2007, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.

DO NOT ENTER: /M.R./